

jc925 U.S. PTO  
10/057009

01/24/02

U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10057009	01 24 2002	438		2812	

**\*\*APPLICANTS:** Chen Wei-Su, Su Hui-Chi, Chen Yi-Shian, Liang Chao-Chiun, Lee Cheng, Juang Jeng

**\*\*CONTINUING DATA VERIFIED:** *None*

**\*\* FOREIGN APPLICATIONS VERIFIED:** *None*

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	64 600-095
Verified and Acknowledged Examiner's Initials <i>WJ</i>		
TITLE : Micro fabrication with vortex shaped spirally topographically tapered spirally patterned conductor layer and method for fabrication thereof		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Application Examiner	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	
<b>WARNING:</b> The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)